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Notice of References Cited	Application/Control No. 09/815,337	Applicant(s)/Patent Under Reexamination CEDERVALL ET AL.	
	Examiner Nawara T. Omary	Art Unit 2683	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,835,857	11-1998	Otten, David D.	455/410
	C	US-5,973,643	10-1999	Hawkes et al.	342/457
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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